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IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Toshiaki ASHAI et al.

Group:

1722

Application No.:

10/502,228

Examiner:

Felisa Carla Hiteshew

Filed:

July 22, 2004

Conf.:

1500

For:

PRODUCTION METHOD FOR COMPOUND SEMICONDUCTOR SINGLE

CRYSTAL

REQUEST FOR CLARIFICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

MAR 28 2007

Sir:

We have recently received the Notice of Allowability (Form PTOL-37) in the above-identified case. In reviewing the Form PTOL-37, it has been discovered that the allowed claims are incorrectly shown as claims 1, 2, 5 and 9-12. Therefore, it is requested that the Examiner issue a corrected Form PTOL-37 indicating that the correct allowable claims are claims 1, 2, 5 and 8-12, which equal a total of 8 claims.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §1.16 or under 37 C.F.R. §1.17; particularly, extension of time fees.

Respectfully submitted,

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